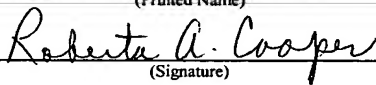




Atty. Dkt. No. 039153-0642 (H0970)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Paton et al.
Title: OFFSET SPACER SMOS
PROCESS FOR FORMING
N-TYPE TRANSISTORS
Appl. No.: 10/619877
Filing Date: 07/15/2003
Examiner: Jeff B. Vockrodt
Art Unit: 2822
Confirmation No.: 7818

CERTIFICATE OF EXPRESS MAILING	
I hereby certify that this correspondence is being deposited with the United States Postal Service's "Express Mail Post Office To Addressee" service under 37 C.F.R. § 1.10 on the date indicated below and is addressed to: Commissioner for Patents, PO Box 1450, Alexandria, Virginia 22313-1450.	
EV 431583642 US	06/24/04
(Express Mail Label Number)	(Date of Deposit)
Roberta A. Cooper	
(Printed Name)	
	
(Signature)	

AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop NON-FEE AMENDMENT
Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

This communication is responsive to the Non-Final Office Action dated March 29, 2004, concerning the above-referenced patent application.

Amendments to the Specification begin on page 2 of this document.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this document.

Remarks/Arguments begin on page 7 of this document.

Please amend the application as follows: